# PATENT APPLICATION

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of

Docket No: Q83944

Hiroto OHTAKE, et al.

Appln. No.: 10/509,898

Group Art Unit: 2812

Confirmation No.: 2975

Examiner: Cheung LEE

Filed: October 1, 2004

For:

SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

# AMENDMENT UNDER 37 C.F.R. § 1.111

### MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 5, 2006, please amend the above-identified application as follows on the accompanying pages.

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REMARKS	